

Modification Highlights for VR-203-F and VR-204-F

Executive Order

- Legal Language and Executive Order exhibits have been updated to reflect new revision level.
- Amended Exhibit 1 of VR-203 to make the “TLS Console” equipment the same as listed in VR-204.
- Amended Exhibit 2 to update the Exhibit 6 test criteria (see below) for the VST ECS Membrane Processor. Also, changed the Exhibit 12 test criteria from % by volume units to ppmv units.
- Amend Exhibit 6 to change the criteria for the high range gas from $\pm 1.0\%$ to $\pm 2.0\%$.
- Amend Exhibit 11, “Veeder-Root Vapor Polisher Operability Test Procedure.” Amend Section 4.2 to read “...with a full scale of zero to 20 or 40 scfh.” Amend Sections 5.2 and 5.3 to require accuracy checks “...at a minimum of three (3) points...” Amend Section 8 and Form 1 to clarify that only a decrease in pressure greater than 0.5 inches WC is a test failure (i.e., a pressure increase during the test is not considered a test failure.)
- Amend Exhibit 12, “Veeder-Root Vapor Polisher Hydrocarbon Emissions Verification Test Procedure.” Changed primary units from % by volume to ppmv. Amend Section 5.1 to require accuracy checks “...at a minimum of three (3) points...”
- Made other minor changes for safety, clarity, and consistency.

ISD

- Amended Exhibit 2 to add alternate vapor vent stack pressure sensor installation. Add illustration 2B-12 of vent stack installation configuration.
- Amend Exhibit 9 adding alternate vapor vent stack pressure sensor language.

IOM

- Decreased the minimum static load from 100 pounds to 88 pounds.
- Added an “Alternate Vent Stack Installations” Section
- Added an Exhibit 12 “Test Port Installation” Section.
- Added a protective boot, with installation instructions, to cover the thermal probe.